

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mark S. Chace et al.

Examiner: Joseph W. Drodge

Serial No.: 10/695,374

Art Unit: 1723

Filed: October 28, 2003

Docket: FIS920030172US1 (16645)

For: PROCESS FOR REMOVING
IMPURITIES FROM LOW
DIELECTRIC CONSTANT
FILMS DISPOSED ON
SEMICONDUCTOR DEVICES

Dated: March 2, 2007

Confirmation No.: 5323

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Official Action dated December 29, 2006, please amend the above-identified application as follows:

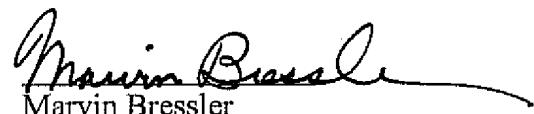
Amendment to the claims begin at Page 2 of this paper.

Remarks/Arguments begin at Page 9 of this paper.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on March 2, 2007.

Dated: March 2, 2007



Marvin Bressler